

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Johannes BAUR et al.

Serial No.: 10/529,625

Filed: November 18, 2005

For: Radiation-Emitting Semiconductor Component
and Method for the Production thereof

Examiner: Wilson, Scott R.
Group Art: 2826

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

S I R:

In compliance with the duty of disclosure under 37 C.F.R. §1.56 and in accordance with the practice under 37 C.F.R. §§1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO/SB/08a. Copies of the listed documents are also enclosed.

Each item of information contained in the Information Disclosure Statement was first cited in an Office Action received from the Japanese Patent Office (copy of English translation enclosed) in a counterpart Japanese patent application not more than three months prior to the filing of the Information Disclosure Statement.

The remaining document (WO 01/61764) listed on the Japanese Office Action was already listed in the Information Disclosure Statement that was submitted on March 30, 2005.

In accordance with 37 C.F.R §§1.97(g) and (h), the filing of this Information Disclosure Statement should not be construed as a representation that a search has been made or that information cited is, or is considered to be, material to patentability as defined in §1.56(b), or that any cited document listed or attached is (or constitutes) prior art. Unless otherwise indicated, the date of publication indicated for an item is taken from the face of the item and Applicant reserves the right to prove that the date of publication is in fact different.

This information is being submitted after issuance of a Notice of Allowance, but before payment of the Issue Fee.

A check in the amount of \$180.00 in payment of the appropriate fee is enclosed herewith. It is believed that no additional fees or charges are required at this time in connection with the present application. However, if any fees or charges are required at this time, they may be charged to our Patent and Trademark Office Deposit Account No. 03-2412.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO/SB/08A be returned indicating that such information has been considered.

Respectfully submitted,
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